



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
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Title of Invention	METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE																																																																				
Application Number:		09/841800																																																																			
Confirmation Number:		6810																																																																			
First Named Applicant:		Maximilian Biberger																																																																			
Attorney Docket Number:																																																																					
Search string:		(20030008238 or 20030008518 or 20030013311 or 20030036023 or 20030047533).pn.																																																																			
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Electronic Filing System (EFS) Data

Electronic Patent Application Submission

USPTO Use Only

EFS ID: 50641

Application ID: 09841800



Title of Invention:
METHOD OF DEPOSITING METAL
FILM AND METAL DEPOSITION
CLUSTER TOOL INCLUDING
SUPERCritical
DRYING/CLEANING MODULE

First Named Inventor: Maximilian Biberger

Domestic/Foreign Application: Domestic Application

Filing Date: 2001-04-24

Effective Receipt Date: 2003-11-14

Submission Type: Information Disclosure
Statement

Filing Type:

Confirmation number: 6810

Attorney Docket Number: NONE

Total Fees Authorized:

Digital Certificate Holder: cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
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Title of Invention	METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE	
Application Number:	09/841800	
Date:	2001-04-24	NOV 18 2003 RECEIVED
First Named Applicant:	Maximilian A. Biberger	
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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney
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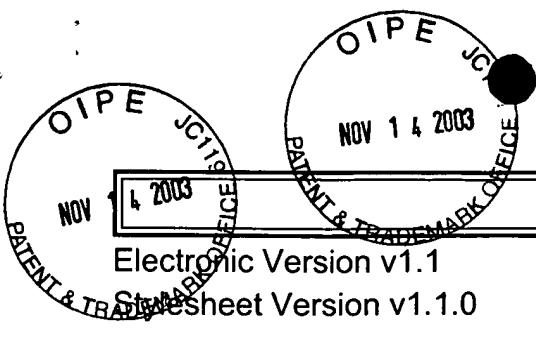
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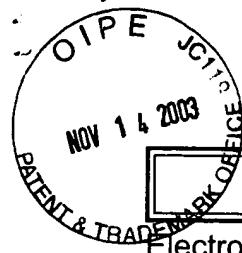
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	1	6251250	2001-06-26	Keigler	B1		
	2	6255732	2001-07-03	Yokoyama et al.	B1		
	3	6270531	2001-08-07	DeYoung et al.	B1		
	4	6270948	2001-08-07	Sato et al.	B1		
	5	6277753	2001-08-21	Mullee et al.	B1		
	6	6284558	2001-09-04	Sakamoto	B1		
	7	6286231	2001-09-11	Bergman et al.	B1		

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	9	6331487	2001-12-18	Koch	B1
	10	6344243	2002-02-05	McClain et al.	B1
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	21	6486078	2002-11-26	Rangarajan et al.	B1
	22	6486282	2002-11-26	Dammel et al.	B1
	23	6492090	2002-12-10	Nishi et al.	B1
	24	6500605	2002-12-31	Mullee et al.	B1
	25	6558475	2003-05-06	Jur et al.	B1
	26	6562146	2003-05-13	DeYoung et al.	B1

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

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	1	20010019857	2001-09-06	Yokoyama et al	A1		
	2	20010024247	2001-09-27	Nakata	A1		
	3	20010041455	2001-11-15	Yun et al.	A1		
	4	20010041458	2001-11-15	Ikakura et al.	A1		
	5	20020001929	2002-01-03	Biberger et al.	A1		
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	13	20020112746	2002-08-22	DeYoung et al.	A1
	14	20020115022	2002-08-22	Messick et al.	A1
	15	20020117391	2002-08-29	Beam	A1
	16	20020123229	2002-09-05	Ono et al.	A1
	17	20020127844	2002-09-12	Grill et al.	A1
	18	20020132192	2002-09-19	Namatsu	A1
	19	20020141925	2002-10-03	Wong et al.	A1
	20	20020142595	2002-10-03	Chiou	A1
	21	20020150522	2002-10-17	Heim et al.	A1
	22	20030003762	2003-01-02	Cotte et al.	A1

Remarks

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Electronic Patent Application Submission

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EFS ID: 50639
Application ID: 09841800 

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First Named Inventor: Maximilian Biberger

Domestic/Foreign Application: Domestic Application

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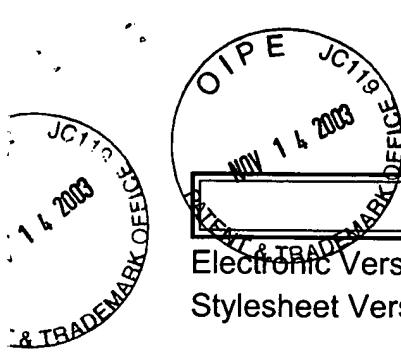
Confirmation number: 6810

Attorney Docket Number: NONE

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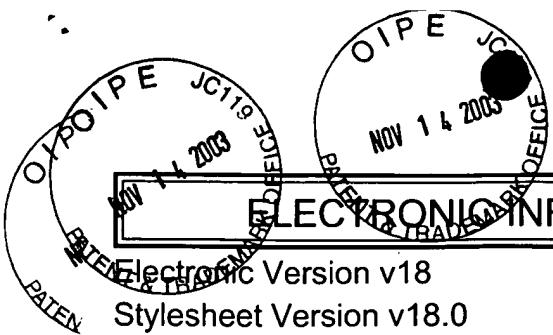
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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

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	17	6171645	2001-01-09	Smith et al.	B1
	18	6200943	2001-03-13	Romack et al.	B1
	19	6216364	2001-04-17	Tanaka et al.	B1
	20	6224774	2001-05-01	DeSimone et al.	B1
	21	6228826	2001-05-08	DeYoung et al.	B1
	22	6232238	2001-05-15	Chang et al.	B1
	23	6232417	2001-05-15	Rhodes et al.	B1
	24	6239038	2001-05-29	Wen	B1

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Title of Invention	METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE																																																				
Application Number: 09/841800																																																					
Confirmation Number: 6810																																																					
First Named Applicant: Maximilian Biberger																																																					
Attorney Docket Number:																																																					
Search string: (5370741 or 5714299 or 5725987 or 5736425 or 5766367).pn.			NOV 18 2003 RECEIVED																																																		
US Patent Documents																																																					
Note: Applicant is not required to submit a paper copy of cited US Patent Documents																																																					
<table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th></tr><tr><th></th><th></th><th></th><th></th><th></th><th>Class</th></tr><tr><th></th><th></th><th></th><th></th><th></th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>5370741</td><td>1994-12-06</td><td>Bergman</td><td></td></tr><tr><td></td><td>2</td><td>5714299</td><td>1998-02-03</td><td>Combes et al.</td><td></td></tr><tr><td></td><td>3</td><td>5725987</td><td>1998-03-10</td><td>Combes et al.</td><td></td></tr><tr><td></td><td>4</td><td>5736425</td><td>1998-04-07</td><td>Smith et al.</td><td></td></tr><tr><td></td><td>5</td><td>5766367</td><td>1998-06-16</td><td>Smith et al.</td><td></td></tr></tbody></table>						init	Cite.No.	Patent No.	Date	Patentee	Kind						Class						Subclass		1	5370741	1994-12-06	Bergman			2	5714299	1998-02-03	Combes et al.			3	5725987	1998-03-10	Combes et al.			4	5736425	1998-04-07	Smith et al.			5	5766367	1998-06-16	Smith et al.	
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Electronic Filing System (EFS) Data

Electronic Patent Application Submission

USPTO Use Only

EFS ID: 50637
Application ID: 09841800 

Title of Invention: METHOD OF DEPOSITING METAL
FILM AND METAL DEPOSITION
CLUSTER TOOL INCLUDING
SUPERCritical
DRYING/CLEANING MODULE

First Named Inventor: Maximilian Biberger
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-04-24
Effective Receipt Date: 2003-11-14
Submission Type: Information Disclosure Statement
Filing Type:
Confirmation number: 6810
Attorney Docket Number: NONE

Total Fees Authorized: 180.0
Payment Category: Deposit Account
Deposit Account Number: 81275
Deposit Account Name: Thomas B. Haverstock
Access Code: ****
RAM Payment Status: RAM success
RAM User ID: EFSPROD
RAM Accounting Date: 2003-11-14
RAM Sequence Number: 24

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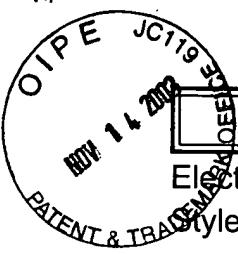
Stylesheet Version v1.1.0

Title of Invention	METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE	
Application Number:	09/841800	
Date:	2001-04-24	NOV 18 2003 RECEIVED
First Named Applicant:	Maximilian A. Biberger	
Confirmation Number:	6810	
Attorney Docket Number:		
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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney
Documents being submitted	Files	
us-fee-sheet	SSI02001A-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd	
us-ids	SSI02001A-usidst.xml us-ids.dtd us-ids.xsl	



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Title of Invention

METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE

Application Number: 09/841800



Date: 2001-04-24

First Named Applicant: Maximilian A. Biberger

Attorney Docket Number:

TOTAL FEE AUTHORIZED \$180

Patent fees are subject to annual revisions on or about October 1st of each year.

BASIC FILING FEE

Fee Description	Fee Code	Amount \$	Fee Paid \$
Submission Of Information Disclosure Stmt Fee	1806	180	180

AUTHORIZED BILLING INFORMATION

The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:

Deposit account number: 081275

Access Code ****

Deposit name: Haverstock and Owens LLP

Deposit authorized name: Thomas B. Haverstock

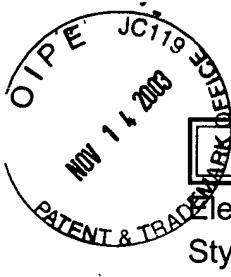
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Deposit name:	Haverstock and Owens LLP		
Deposit authorized name:	Thomas B. Haverstock		
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Date (YYYYMMDD):	2003-11-14		
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First Named Applicant: Maximilian Biberger
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Search string: (2439689 or 4349415 or 4925790 or 5071485
or 5196134 or 5269850 or 5285352 or
5320742).pn.



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	2439689	1948-04-13	Hyde et al.			
	2	4349415	1982-09-14	DeFilippi et al.			
	3	4925790	1990-05-15	Blanch et al.			
	4	5071485	1991-12-10	Matthews et al.			
	5	5196134	1993-03-23	Jackson			
	6	5269850	1993-12-14	Jackson			
	7	5285352	1994-02-08	Pastore et al.			
	8	5320742	1994-06-14	Fletcher et al.			

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Remarks

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Examiner Name	Date